



AF (IR)  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/594,635                      Group Art Unit: 1793  
Filing Date: September 28, 2006              Examiner: Shuangyi Abu Ali  
Applicant: Yoshiharu OHTA et al.  
Title: SEMICONDUCTOR POLISHING COMPOSITION (As Amended)  
Attorney Docket: 2691-000050/US

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Date: December 29, 2009

**REQUEST FOR RECONSIDERATION**

Sir:

In response to the Office Action mailed August 10, 2009, the shortened statutory period for reply being extended to January 10, 2010 by the attached Extension of Time, the following remarks are respectfully submitted.

**A listing of the Claims** begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	12	-	20	=	0
Independent	1	-	3	=	0